



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Toshihiro HAYAMI, et al.

SERIAL NO: 10/724,693

GAU: 1763

FILED: December 2, 2003

EXAMINER: KACKAR, RAM N.

FOR: TEMPERATURE MEASURING METHOD AND PLASMA PROCESSING APPARATUS

REQUEST FOR EXTENSION OF TIME  
UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a **one** month extension of time be granted to February 19, 2006 for

- filing a response to the Official Action dated: October 19, 2005
- responding to the requirements in the Notice of Allowability dated:
- filing the Formal Drawings. The Issue Fee due has been timely filed.
- responding to the Notice to File Missing Parts of Application dated:
- filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- filing an Appeal Brief. A Notice of Appeal was filed on:
- Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$120.00 is enclosed herewith by credit card payment and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

  
Steven P. Weihrouch

Registration No. 32,829

Customer Number

22850

Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 05/03)  
I:\ATTY\JL\246076US\246076 EOT.DOC

02/22/2006 100001 00000053 10724693  
Raymond P. Cardillo, Jr. 120.00 OP  
Registration No. 46,1251 40,440

Philip J. Hoffmann  
Registration No. 46,340